orm 1449 (Modified) Application No.: Atty Docket No. 09/699,108 **NEV1P002** RECEIVED Applicant: **Information Disclosure** Hensen Mou **Statement By Applicant** JUL 2 5 2001 Filing Date Group Technology Center 2600 2661 October 26, 2000 (Use Several Sheets if Necessary)

U.S. Patent Documents

	CIST LECHT DOCUMENTS							
Examiner						Sub-	Filing	
Initial	No.	Patent No.	Date	Patentee	Class	class	Date	
PS	A1	5,133,079	07/21/92	Ballantyne, et al	455	4.1	08/28/90	
PS	A2	5,550,577	08/27/96	Verbiest, et a;	348	7	05/19/94	
ρs	A3	5,577,191	11/19/96	Mauro Bonomi	395	502	02/17/94	
PS	A4	5,579,308	11/26/96	Humpleman	370	58.1	11/22/95	
PS	A5	5,784,571	07/21/98	Mantopoulos, et al	395	200.77	12/14/95	
ρs	A6	5,886,732	03/23/99	Humpleman	348	10	11/22/95	
75	A7	5,940,387	08/12/99	Humpleman	370	352	06/17/97	
PS	A8	6,055,560	04/25/00	Mills, et al	709	200	11/08/96	

Foreign Patent or Published Foreign Patent Application

		J. J. 5						
Examiner		Document	Publication	Country or		Sub-	Trans	lation
Initial	No.	No.	D ate	Patent Office	Class	class	Yes	No
	B1							
	B2							

Other Documents

		Other Documents
Examiner		
Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
	C2	
	C3	
	C4	
	C5	
	C6	
	C7	
Examiner		Date Considered 9/24/04
 _		

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 1449 (Modified)

Atty Docket No.
NEV1P002
09/699,108

Application No.:
NEV1P002
Applicant:
Hensen Mou
Filing Date
Group
Q (Use Several Sheets if Necessary)

October 26, 2000

Application No.:
Op/699,108

JAN 2 5 2002 W

U.S. Patent Documents

xaminer						Sub-	Filing
Initial	No.	Patent No.	Date	Patentee	Class	class	Date
PS	Α	5,956,716	09/21/99	Kenner, et al.			06/07/96
PS	В	6,005,861	12/21/99	Humpleman			03/03/99
PS	С	6,018,765	01/25/00	Durana, et al.			01/23/97
	D						
	Е				·		
	F						
	G						

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	lation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	Н							
	I							
	J							
	K							
	L							

Other Documents

ECEIVED
FEB 0 4 2002
nology Center 2600
24/04

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 3449 (Modified)

Information Disclosure
Statement By Applicant

(Use Several Sheets if Necessary)

Atty Docket No. Application No.:

NEV1P002
Applicant:
Hensen Mou
Filing Date
Group
2661

U.S. Patent Documents

Examiner						Sub-	Filing
Inițial	No.	Patent No.	Date	Patentee	Class	class	Date
195	A1	5,659,539	08/19/1997	Porter, et al.			07/14/1995
PS	A2	5,818,439	10/06/1998	Nagasaka, et al.			02/16/1996
PS	A3	6,020,912	02/01/2000	De Lang			07/09/1996
PS	A4	6,549,216	04/15/2003	Schumacher, et al.			08/12/1999
					RE	ECE	VED
	ļ.,					UL 0.7	2004
					 	OL U. I	2007
	1				1 Techn	ology Ce	hter 2600

Foreign Patent or Published Foreign Patent Application

Examiner		Document	Publication	Country or		Sub-	Trans	slation
Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
	1							
						1		

Other Documents

No.	Author, Title, Date, Place (e.g. Journal) of Public	ation
K	him	Date Considered	9/24/04
	No.	No. Author, Title, Date, Place (

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.